A SEMICONDUCTOR CIRCUIT DESIGNING APPARATUS AND A SEMICONDUCTOR CIRCUIT DESIGNING METHOD IN WHICH THE NUMBER OF STEPS IN A CIRCUIT DESIGN AND A LAYOUT DESIGN IS REDUCED

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Background of the Invention

1. Field of the Invention

The present invention relates to a semiconductor circuit designing apparatus and a

10 semiconductor circuit designing method. More particularly, the present invention relates to a semiconductor circuit designing apparatus and a semiconductor circuit designing method, which are used in a silicon interface field of an ASIC development so

15 as to further reduce the number of steps in a circuit design and a layout design.

2. Description of the Related Art

In a field of a semiconductor design, a

20 division between a circuit design and a layout design is advanced as a circuit becomes large and complex, and the respective automations are advanced. In such division, an acceptance inspection is executed for examining whether or not a circuit information

25 interfaced so as to minimize a backward motion of a step is reasonable. Inspection items for such an acceptance inspection are different depending on a

circuit feature, such as a circuit configuration, a test simplifying method to be used and the like. So, the items of the acceptance inspection to be executed are determined depending on the circuit feature.

5   A layout designer carries out all necessary acceptance inspections for each model, on the basis of the circuit information prepared by the circuit designer. So, a number of steps are needed in order to execute the acceptance inspection and confirm the

10 result. Or, there may be a case that an acceptance inspection on the layout designer side is omitted by inquiring the executed inspection items of the circuit designer. However, an answer (entry) miss on the circuit designer side, a misunderstanding or the like

15 causes an erroneous result to be reported, which results in the backward motion of the step (iteration) in many cases.

A known drawing validation system disclosed in Japanese Laid Open Patent Application (JP-A-Heisei,

20 10-198708) includes a first memory for storing a data indicative of a drawing, a second memory for storing a data indicative of a predetermined condition and a judging unit for judging whether or not the drawing agrees with the predetermined condition. Such a

25 drawing validation system can automatically validate whether or not an item specified on the basis of a know-how and an experience of the circuit designer is

accurately reflected to thereby prepare a drawing of a
layout of a printed circuit board, without any manual
work. Thus, it is possible to prepare the drawing
with high quality in a short time.

5   This drawing validation system relates to a
determination of an inspection item and an inspection
execution in a single drawing validation system to be
used by the layout designer. Its applicable
department is limited to the layout designer side.

10   Thus, it does not disclose a method to be used for the
circuit designer to avoid a problem.

    Japanese Laid Open Patent Application (JP-A-
Heisei, 10-79435) discloses the following
semiconductor development information integrating

15   apparatus. In a semiconductor information managing
apparatus, the electronic data based on a photo-mask
specification prepared in a semiconductor design and
the electronic data in respective manufacturing
processes prepared in a semiconductor manufacturing

20   process are stored and managed in a same data or a
plurality of databases as an integrated semiconductor
information. Thus, the information with regard to a
CAD apparatus, a semiconductor manufacturing
electronic terminal and a semiconductor manufacturing

25   apparatus are shared.

Summary of the Invention

The present invention is accomplished in view of the above mentioned problems. Therefore, an object of the present invention is to provide a semiconductor circuit designing apparatus and a semiconductor circuit designing method, in which an iteration, such as a re-design and the like, caused by a design trouble can be reduced.

Another object of the present invention is to provide a semiconductor circuit designing apparatus and a semiconductor circuit designing method, in which inspection items can be reduced.

Still another object of the present invention is to provide a semiconductor circuit designing apparatus and a semiconductor circuit designing method, in which a burden of a number of steps on a circuit designer can be reduced.

Still another object of the present invention is to provide a semiconductor circuit designing apparatus and a semiconductor circuit designing method, in which a burden of a number of steps on a layout designer can be reduced.

In order to achieve an aspect of the present invention, a semiconductor circuit designing apparatus, includes: a circuit design unit executing a logical design of a semiconductor integrated circuit; and an inspection item database section in which a circuit feature of the semiconductor integrated circuit

corresponds to an inspection item of a inspection to be executed before a layout design of the semiconductor integrated circuit is executed, and wherein the circuit design unit generates a target circuit feature information indicating the circuit feature of a target semiconductor integrated circuit of the semiconductor integrated circuit of which the logical design should be executed, and wherein the circuit design unit obtains a target inspection item of the inspection item corresponding to the target circuit feature information from the inspection item database section, and wherein the circuit design unit executes the logical design of the target semiconductor integrated circuit in reference to the target inspection item.

In this case, the semiconductor circuit designing apparatus further includes: a model development history database section in which an ID data of the circuit design unit corresponds to the number of times the circuit design unit failed the inspection of the inspection item previously, and wherein the target inspection item is determined such that the inspection item of which the number of times is smaller than a predetermined value is withdrawn from the target inspection item.

Also in this case, the semiconductor circuit designing apparatus further includes: a layout design

unit executing the layout design, and wherein the circuit design unit executes the inspection of the target semiconductor integrated circuit of which the layout design is executed, with regard to the target

5   inspection item, and wherein the circuit design unit provides a result of the inspection with the target semiconductor integrated circuit to the layout design unit.

Further in this case, the semiconductor circuit

10   designing apparatus further includes: a layout design unit executing the layout design, and wherein the circuit design unit executes the inspection of the target semiconductor integrated circuit of which the layout design is executed, with regard to the target

15   inspection item, and wherein the circuit design unit provides a result of the inspection with the target semiconductor integrated circuit to the layout design unit.

In this case, when the provided result of the

20   inspection has no problem, the layout design unit stores the ID data of the circuit design unit and the number of times the circuit design unit failed the inspection of the target inspection item in the model development history database section.

25   Also in this case, the inspection item database section belongs to the circuit design unit.

Further in this case, the inspection item

database section belongs to the circuit design unit.

In this case, the inspection item database section belongs to the layout design unit.

Also in this case, the inspection item database section belongs to the layout design unit.

Further in this case, the inspection item database section belongs to the layout design unit.

In this case, the layout design unit includes a plurality of layout design sections, and wherein the inspection item database section belongs to at least one of the plurality of layout design sections.

Also in this case, the semiconductor circuit designing apparatus further includes: a data center provided to be different from the circuit design unit and the layout design unit, and wherein the inspection item database section belongs to the data center.

In order to achieve another aspect of the present invention, a semiconductor circuit designing method, includes: (a) providing a inspection item database section in which a circuit feature of a semiconductor integrated circuit in which a logical design should be executed corresponds to an inspection item of a inspection to be executed before a layout design of the semiconductor integrated circuit is executed; (b) notifying a circuit designer executing the logical design of the semiconductor integrated circuit of the inspection item corresponding to the

semiconductor integrated circuit retrieved from the

inspection item database section; and (c) executing

the logical design of the semiconductor integrated

circuit by the circuit designer in reference to the

5   notified inspection item.

In this case, the semiconductor circuit

designing method, further includes: (d) providing the

semiconductor integrated circuit in which the notified

inspection item is passed to a layout designer

10   executing the layout design.

In order to achieve still another aspect of the

present invention, the semiconductor circuit designing

method, includes: (e) providing a circuit design unit

executing a logical design of a semiconductor

15   integrated circuit; and (f) providing an inspection

item database section in which a circuit feature of

the semiconductor integrated circuit corresponds to an

inspection item of a inspection to be executed before

a layout design of the semiconductor integrated

20   circuit is executed, and wherein the circuit design

unit generates a target circuit feature information

indicating the circuit feature of a target

semiconductor integrated circuit of the semiconductor

integrated circuit of which the logical design should

25   be executed, and wherein the circuit design unit

obtains a target inspection item of the inspection

item corresponding to the target circuit feature

information from the inspection item database section,
and wherein the circuit design unit executes the
logical design of the target semiconductor integrated
circuit in reference to the target inspection item.

5   In this case, the semiconductor circuit
designing method further includes: (g) providing a
model development history database section in which an
ID data of the circuit design unit corresponds to the
number of times the circuit design unit failed the

10   inspection of the inspection item previously, and
wherein the target inspection item is determined such
that the inspection item of which the number of times
is smaller than a predetermined value is withdrawn
from the target inspection item.

15   Also in this case, the semiconductor circuit
designing method further includes: (h) providing a
layout design unit executing the layout design, and
wherein the circuit design unit executes the
inspection of the target semiconductor integrated

20   circuit of which the layout design is executed, with
regard to the target inspection item, and wherein the
circuit design unit provides a result of the
inspection with the target semiconductor integrated
circuit to the layout design unit.

25   Further in this case, the semiconductor circuit
designing method further includes: (i) providing a
layout design unit executing the layout design, and

wherein the circuit design unit executes the
inspection of the target semiconductor integrated
circuit of which the layout design is executed, with
regard to the target inspection item, and wherein the
5   circuit design unit provides a result of the
inspection with the target semiconductor integrated
circuit to the layout design unit.

In this case, when the provided result of the
inspection has no problem, the layout design unit
10   stores the ID data of the circuit design unit and the
number of times the circuit design unit failed the
inspection of the target inspection item in the model
development history database section.

Also in this case, the inspection item database
15   section belongs to the circuit design unit.

Brief Description of the Drawings

FIG. 1 is a block diagram showing a
configuration of a semiconductor design system
20   according to a embodiment of the present invention;

FIG. 2 is a table of a check sheet of a
semiconductor design system according to a embodiment
of the present invention;

FIG. 3 is a table of a inspection item database
25   of a semiconductor design system according to a
embodiment of the present invention;

FIG. 4 is a table of a model development

history database of a semiconductor design system

according to a embodiment of the present invention;

FIG. 5 is a flow chart of semiconductor design

method according to a embodiment of the present

5   invention;

FIG. 6 is a flow chart of semiconductor design

method according to a embodiment of the present

invention;

FIG. 7 is a flow chart of semiconductor design

10   method according to another embodiment of the present

invention;

FIG. 8 is a flow chart of semiconductor design

method according to another embodiment of the present

invention;

15   FIG. 9 is a flow chart of semiconductor design

method according to still another embodiment of the

present invention;

FIG. 10 is a flow chart of semiconductor design

method according to still another embodiment of the

20   present invention;

FIG. 11 is a block diagram showing a

configuration of a semiconductor design system

according to another embodiment of the present

invention;

25   FIG. 12 is a flow chart of semiconductor design

method according to yet still another embodiment of

the present invention;

FIG. 13 is a flow chart of semiconductor design method according to yet still another embodiment of the present invention; and

FIG. 14 is a block diagram showing a
5   configuration of a semiconductor design system according to still another embodiment of the present invention.

Description of the Preferred Embodiments

10   With reference to the attached drawings, an embodiment of a semiconductor designing system according to the present invention, a plurality of engineering workstations (hereafter, abbreviated as [EWS]) are connected to each other. The plurality of
15   EWS are provided with a circuit design EWS1 and a layout design EWS2. They are connected to each other through a network 3.

The circuit design EWS1 is installed for each circuit designer and used for a circuit design. For
20   example, the circuit design EWS1 belongs to a circuit designer A, and a circuit design EWS1' belongs to a circuit designer B. Circuit designers ID different from each other are assigned to the circuit designers. The circuit designer ID is used to identify the
25   circuit designer and identify a right under which the circuit designer accesses the layout design EWS2. The circuit designer is one person or a plurality of

persons attached to one group. That group is an

enterprise, a department within an enterprise, a

design group within a department or the like. The

circuit design EWS1 has a check sheet 4. The check

5   sheet 4 is an interface file in which a circuit

feature of a semiconductor integrated circuit, an

inspection item and an inspection result are noted.

The check sheet 4 is prepared for each circuit design.

The layout design EWS2 belongs to a layout

10   designer, and it is used for the layout design. The

layout designer gives the circuit designer ID to each

circuit designer. The layout design EWS2 has an

inspection item database 6 and a model development

history database 7. The inspection item database 6 is

15   noted while a circuit feature and an inspection item

necessary for the circuit feature are correlated to

each other. The model development history database 7

is noted while a circuit designer ID of a designing

circuit designer, a circuit feature of a previously

20   designed semiconductor integrated circuit and a

frequency of errors occurring in the development step

are correlated to each other.

Fig. 2 shows an actual example of the check

sheet 4. The circuit feature, the inspection item and

25   an inspection result are noted in the check sheet 4.

A technology, a condition, a model name, a package, a

number of pins, a presence or absence of a usage of a

test simplifying method are noted as the circuit

feature. The test simplifying method uses a scan, a

boundary scan and RAM. A net list check, a pattern

check, a scan check, a timing check and the like are

5   noted as the inspection items.

In the semiconductor integrated circuit

according to this embodiment on which the acceptance

inspection is performed, the technology is CMOS9HD,

the condition is 3.3 V, the model name is 65956E00,

10   the package is TBG, and the number of pins is 420 pins.

Moreover, the scan manner of the test simplifying

method is used without using the boundary scan and the

RAM. The inspection items necessary for this

semiconductor integrated circuit are the net list

15   check, the pattern check, the scan check and the

timing check. As the inspection result, there is no

error in the net list check, there are two errors in

the pattern check, the scan check is not executed, and

there is no error in the timing check.

20   Fig. 3 shows an actual example of the

inspection item database 6. As for the semiconductor

integrated circuit, the inspection items are different

depending on the circuit feature. The inspection

items necessary for the respective circuit features of

25   the semiconductor integrated circuit are noted in the

inspection item database 6. As the circuit feature,

there are a basic configuration, a usage of the scan,

a usage of the boundary scan, a usage of the RAM, a test bus configuration and the like. As the inspection items, there are the net list check, the pattern check, the scan check, the boundary scan check,

5 the timing check, a test terminal check and a RAM check.

If the semiconductor integrated circuit on which the acceptance inspection is performed is designed by only the basic configuration, the

10 inspection items in the acceptance inspection that must be executed are the net list check, the pattern check and the timing check. If the semiconductor integrated circuit on which the acceptance inspection is performed employs the scan manner that is the test

15 simplifying method, the inspection items in the acceptance inspection that must be executed are the net list check, the pattern check, the scan check and the timing check.

If the semiconductor integrated circuit on

20 which the acceptance inspection is performed employs the boundary scan manner that is the test simplifying method, the inspection items in the acceptance inspection that must be executed are the net list check, the pattern check, the boundary scan check and

25 the timing check. If the semiconductor integrated circuit on which the acceptance inspection is performed employs the RAM, they are the net list check,

the pattern check, the timing check and the RAM check. If the semiconductor integrated circuit on which the acceptance inspection is performed has the test bus configuration, the inspection items in the acceptance

5 inspection that must be executed are the net list check, the pattern check, the timing check and the test terminal check.

Such an inspection item database 6 clarifies the inspection items in the acceptance inspection to

10 be executed. This results in the sure execution of the acceptance inspection.

Fig. 4 shows an actual example of the model development history database 7. In the model development history database 7, the designer ID, the

15 circuit feature and the inspection result are noted while they are correlated to each other, for each semiconductor integrated circuit.

For example, in a case of a semiconductor integrated circuit having a model name of 6595E00 that

20 is designed by a circuit designer whose circuit designer ID is AAA, its technology is COMS9HD, its condition is COMS3,3V, and its package is TBG. As the various inspection results of this semiconductor integrated circuit, there is no error in the net list

25 check, there are two errors in the pattern check, the scan check is not executed, and there is no error in the timing check, in the acceptance inspection

executed on September 11.

In a re-acceptance inspection executed on September 14, there is no error in the net list check, there is no error in the pattern check, the scan check

5　is not executed, and there is no timing check. In a back annotation executed on September 18, there is no error in the net list check, there are two errors in the pattern check, there is no error in the scan check, and there is no error in the timing check.

10　Figs. 5, 6 show the operation of the semiconductor designing system according to the present invention. At first, a circuit designer inputs a circuit designer ID to the circuit design EWS1 (Step S1). The circuit design EWS1 sends the

15　input circuit designer ID through the network 3 to the layout design EWS2.

The layout design EWS2 judges an allowance or rejection of an access in accordance with the circuit designer ID (Step S2). If it is judged that there is

20　no problem in the circuit designer ID, the access is allowed, and the layout design EWS2 reports its fact to the circuit design EWS1. If the access is allowed, the circuit designer inputs to the circuit design EWS1 the circuit feature of a semiconductor integrated

25　circuit to be designed. The circuit design EWS1 sends the circuit feature to the layout design EWS2 (Step S3).

The layout design EWS2 obtains the circuit designer ID and the circuit feature, retrieves an inspection item to be inspected on the basis of the inspection item database 6, and retrieves a previous

5   error of the circuit designer designing the semiconductor integrated circuit on the basis of the model development history database 7 (Step S4). The layout design EWS2 determines an inspection item to be executed at this time on the basis of the retrieved

10   inspection item and error (Step S5).

For example, if there is an inspection item having no problem in five models finally developed by the circuit designer, an execution of the inspection item is exempted. If there is an item in which an

15   error is recorded in the model development history database, the item is determined to be an inspection item to be executed. Such exemption enables the number of inspection items to be reduced on the basis of the experience and the level of the circuit

20   designer. Thus, the burden on the circuit designer is relaxed. If the circuit designer is composed of a plurality of designers, the exempted inspection items are greater to further relax the burden on the circuit designer.

25   The layout design EWS2 sends the determined execution inspection item to the circuit design EWS1. The circuit design EWS1 receives the execution

inspection item from the layout design EWS2, and
writes the inspection items and the circuit feature of
the semiconductor integrated circuit to the check
sheet 4 (Step S6). The circuit design EWS1 displays a
5   previous error content received from the layout design
EWS2 on a screen. The circuit designer designs a
logical circuit while paying attention to the previous
error content and the execution inspection item (Step
S7). Since the item to which the attention must be
10   paid can be obtained at an initial stage of a logical
design, the circuit designer can avoid a logical
design unsuitable for a layout design and accordingly
avoid the re-design (iteration).

If the design of the logical circuit is
15   completed, a logical validation of the logical design
is executed (Step S8). If any trouble is discovered
in the logical validation, the logical design is again
carried out. After the completion of the logical
design, the circuit design EWS1 checks the acceptance
20   inspection item noted in the check sheet 4 (Step S9).
The inspection result is additionally written to the
check sheet 4. If there is a rejected item among the
inspection items noted in the check sheet 4, the
logical design is again carried out. Such re-design
25   can prevent an unnecessary iteration in advance. If
there is no problem in all the items among the
acceptance inspection items, the circuit design EWS1

sends the check sheet 4 together with the design data such as a circuit connection information, a pattern and the like to the layout design EWS2 (Step S10).

The layout design EWS2 compares the execution
5 inspection items noted in the check sheet 4 with the executed result, in response to the reception of the check sheet 4. If there is an inspection item in which the executed result is not noted in the inspection items to be executed, it is judged as a
10 non-execution, and it is returned back to the circuit designer, and the inspection of the non-execution item is requested (Step S11). If there is a result unsuitable for the layout as the result of the acceptance inspection, it is returned back to the
15 circuit designer, and the improvement based on the re-design is requested (Step S12). If the layout has no problem in all the inspection items, the inspection result together with the circuit feature and the circuit designer ID is written to the model
20 development history database 7.

After that, the layout designer designs the layout (Step S13). After the design of the layout, a back annotation is carried out (Step S14). In the back annotation, it is confirmed whether or not the
25 semiconductor integrated circuit carries out a desirably functional operation at a delay after the layout, and additionally writes its result to the

model development history database 7. If the result

of the back annotation is NG, it is returned back to

the circuit designer, and the improvement based on the

re-design is requested. If the result of the back

5   annotation is OK, an EB process is carried out (Step

S15).

By the way, the back annotation may be executed

by the circuit designer. At this time, after the

design of the layout, the layout design data is sent

10 from the layout design EWS2 to the circuit design EWS1,

and the circuit design EWS1 executes the back

annotation. If the back annotation is NG, the logical

design is again carried out. If the back annotation

is OK, the circuit design EWS1 sends its fact to the

15 layout design EWS2. The layout designer carries out

the EB process, in response to the report of the back

annotation OK.

Due to the correspondent consideration between

the previous error and problem and the circuit feature

20 and the circuit designer, the circuit designer can

obtain the items to be considered at the time of the

logical design prior to the designing and thereby

avoid the problem at the stage of the logical design.

Also, since the circuit designer executes the

25 acceptance inspection, the acceptance inspection of

the layout designer is not required, which reduces the

number of steps in the layout designer. Moreover, it

is possible to reduce the request of the re-design to the circuit designer from the layout designer side caused by the defective result of the acceptance inspection. Such dispersion of the process can attain

5   a further reduction in TAT.

Figs. 7, 8 show another operation of the semiconductor designing system according to the present invention. At first, a circuit designer inputs a circuit designer ID to the circuit design

10   EWS1 (Step S21). The circuit design EWS1 sends the input circuit designer ID through the network 3 to the layout design EWS2.

The layout design EWS2 judges an allowance or rejection of an access in accordance with the circuit

15   designer ID (Step S22). If it is judged that there is no problem in the circuit designer ID, the access is allowed, and the layout EWS2 reports its fact to the circuit design EWS1. If the access is allowed, the circuit designer inputs to the circuit design EWS1 the

20   circuit feature of a semiconductor integrated circuit to be designed (Step S23). The circuit design EWS1 sends the circuit feature to the layout design EWS2.

The layout design EWS2 obtains the circuit designer ID and the circuit feature, and retrieves an

25   inspection item to be inspected on the basis of the inspection item database 6, and then retrieves a previous error of the circuit designer designing the

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semiconductor integrated circuit on the basis of the

model development history database 7 (Step S24). The

layout design EWS2 determines an inspection item to be

executed at this time on the basis of the retrieved

5   inspection item and error (Step S5). For example, if

there is an inspection item having no problem in five

models finally developed by the circuit designer, an

execution of the inspection item is exempted. If

there is an item in which an error is recorded in the

10 model development history database, the item is

determined to be an inspection item to be executed.

The layout design EWS2 sends the determined inspection

item to the circuit design EWS1.

The circuit design EWS1 receives the execution

15 inspection item from the layout design EWS2, and

writes the inspection items and the circuit feature of

the semiconductor integrated circuit to the check

sheet 4 (Step S26). The circuit design EWS1 displays

a previous error content received from the layout

20 design EWS2 on the screen. The circuit designer

designs a logical circuit while paying attention to

the previous error content (Step S27). If the design

of the logical circuit is completed, a logical

validation of the logical design is executed (Step

25 S28). If any trouble is discovered in the logical

validation, the logical design is again carried out.

After the completion of the logical design, the

circuit design EWS1 checks the acceptance inspection
item noted in the check sheet 4 (Step S29). The
inspection result is additionally written to the check
sheet 4. If there is a rejected item among the

5 inspection items noted in the check sheet 4, the
logical design is again carried out. If there is no
problem in all the items among the acceptance
inspection items, the circuit design EWS1 sends the
check sheet 4 together with the design data such as a

10 circuit connection information, a pattern and the like
to the layout design EWS2 (Step S30).

The layout design EWS2 compares the execution
inspection items noted in the check sheet 4 with the
executed result, in response to the reception of the

15 check sheet 4 (Step S31). If there is an inspection
item in which the executed result is not noted in the
inspection items to be executed, it is judged as a
non-execution, and its inspection item is inspected
(Step S32). If there is a result unsuitable for the

20 layout as the result of the acceptance inspection, it
is returned back to the circuit designer, and the
improvement based on the re-design is requested (Step
S33). If the layout has no problem in all the
inspection items, the inspection result together with

25 the circuit feature and the circuit designer ID is
written to the model development history database 7.

After that, the layout designer designs the

layout (Step S34). After the design of the layout, the back annotation is carried out (Step S35). The layout design EWS2 additionally writes the result of the back annotation to the model development history

5   database 7. If the result of the back annotation is NG, it is returned back to the circuit designer, and the improvement based on the re-design is requested. The back annotation may be executed by the circuit designer, similarly to the above-mentioned embodiment.

10 If the result of the back annotation is OK, the EB process is carried out (Step S36).

Since the inspection result of the acceptance inspection executed by the circuit designer is written to the check sheet 4, it is not necessary that the

15 same inspection item is again executed in an acceptance inspection on a layout designer side. Moreover, since the number of steps in the acceptance inspection can be reduced, the circuit designer can be devoted entirely to the logical design.

20   Figs. 9, 10 show the operation of the semiconductor designing system according to the present invention. At first, a circuit designer inputs a circuit designer ID to the circuit design EWS1 (Step S61). The circuit design EWS1 sends the

25 input circuit designer ID through the network 3 to the layout design EWS2.

The layout design EWS2 judges an allowance or

rejection of an access in accordance with the circuit

designer ID (Step S62). If it is judged that there is

no problem in the circuit designer ID, the access is

allowed, and the layout EWS2 reports its fact to the

5   circuit design EWS1. If the access is allowed, the

circuit designer inputs to the circuit design EWS1 the

circuit feature of a semiconductor integrated circuit

to be designed. The circuit design EWS1 sends the

circuit feature to the layout design EWS2 (Step S63).

10   The layout design EWS2 obtains the circuit

designer ID and the circuit feature, and retrieves an

inspection item to be inspected on the basis of the

inspection item database 6, and then retrieves a

previous error of the circuit designer designing the

15   semiconductor integrated circuit on the basis of the

model development history database 7 (Step S64). The

layout design EWS2 determines an inspection item to be

executed at this time on the basis of the retrieved

inspection item and error (Step S65). For example, if

20   there is an inspection item having no problem in five

models finally developed by the circuit designer, an

execution of the inspection item is exempted. If

there is an item in which an error is recorded in the

model development history database, the item is

25   determined to be an inspection item to be executed.

The layout design EWS2 sends the determined inspection

item to the circuit design EWS1.

The circuit design EWS1 receives the execution inspection item from the layout design EWS2, and writes the inspection items and the circuit feature of the semiconductor integrated circuit to the check

5   sheet 4 (Step S66). The circuit design EWS1 displays a previous error content received from the layout design EWS2 on the screen. The circuit designer designs a logical circuit while paying attention to the previous error content (Step S67). If the design

10   of the logical circuit is completed, a logical validation of the logical design is executed (Step S68). If any trouble is discovered in the logical validation, the logical design is again carried out.

The circuit design EWS1 examines whether or not

15   there is an item equivalent to the inspection item of the acceptance inspection to be executed among the inspection items in the logical validation. If the equivalent item is included, the inspection result of that item is written to the check sheet 4 (Step S69).

20   Such representation can protect the same inspection from being doubly executed, which can reduce the number of steps in the circuit designer. After that, the circuit design EWS1 checks the acceptance inspection items noted in the check sheet 4 (Step S70),

25   and additionally writes the inspection result to the check sheet 4.

If there is a rejected item among the

inspection items noted in the check sheet 4, the
logical design is again carried out. If there is no
problem in all the items among the acceptance
inspection items, the circuit design EWS1 sends the

5   check sheet 4 together with the design data such as
the circuit connection information, the pattern and
the like to the layout design EWS2 (Step S71).

The layout design EWS2 compares the execution
inspection items noted in the check sheet 4 with the

10   executed result, in response to the reception of the
check sheet 4. If there is an inspection item in
which the executed result is not noted in the
inspection items to be executed, it is judged as a
non-execution, and it is returned back to the circuit

15   designer, and the inspection of the non-execution item
is requested (Step S72). If there is a result
unsuitable for the layout as the inspection result of
the acceptance inspection, it is returned back to the
circuit designer, and the improvement based on the re-

20   design is requested (Step S73). If the layout has no
problem in all the inspection items, the inspection
result together with the circuit feature and the
circuit designer ID is written to the model
development history database 7.

25   After that, the layout designer designs the
layout (Step S74). After the design of the layout,
the back annotation is carried out (Step S75). In the

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back annotation, it is confirmed whether or not the
semiconductor integrated circuit carries out a
desirably functional operation at a delay after the
layout, and additionally writes its result to the
5 model development history database 7. If the result
of the back annotation is NG, it is returned back to
the circuit designer, and the improvement based on the
re-design is requested. If the result of the back
annotation is OK, the EB process is carried out (Step
10 S76).

Fig. 11 shows another embodiment of the
semiconductor designing system according to the
present invention. A circuit design EWS1 has a check
sheet 4 and an inspection item database 6. A layout
15 design EWS2 has a model development history database 7.
At this time, the check sheet 4 is different from the
previous embodiment. A circuit feature and an
inspection result are written thereto, or only an
inspection item to be executed and its inspection
20 result are written thereto.

Figs. 12, 13 show the operation of the
semiconductor designing system according to another
embodiment of the present invention. At first, the
circuit designer inputs to the circuit design EWS1 the
25 circuit feature of the semiconductor integrated
circuit to be designed (Step S41). The circuit design
EWS1 retrieves an error when previously designing the

semiconductor integrated circuit, on the basis of the model development history database 7 (Step S42). The circuit design EWS1 determines an inspection item to be executed at this time, in accordance with the

5   retrieved inspection item (Step S43).

The circuit design EWS1 writes to the check sheet 4 the circuit feature of the semiconductor integrated circuit and the inspection item to be executed (Step S44), and displays the previous error

10   content on the screen. The circuit designer designs the logical circuit while paying attention to the previous error content (Step S45). If the design of the logical circuit is completed, a logical validation of the logical circuit is carried out (Step S46). If

15   any trouble is discovered in the logical validation, the logical design is again carried out.

After the completion of the logical design, the circuit design EWS1 checks the acceptance inspection item noted in the check sheet 4 (Step S47). The

20   inspection result is additionally written to the check sheet 4. If there is a rejected item among the inspection items noted in the check sheet 4, the logical design is again carried out. If there is no problem in all the items among the acceptance

25   inspection items, the circuit designer inputs a circuit designer ID to the circuit design EWS1 (Step S48). The circuit design EWS1 sends the input

circuit designer ID through the network 3 to the layout design EWS2.

The layout design EWS2 judges an allowance or rejection of an access in accordance with the circuit designer ID (Step S49). If it is judged that there is no problem in the circuit designer ID, the access is allowed, and the layout EWS2 reports its fact to the circuit design EWS1. In the circuit designer, if the access is allowed, the circuit design EWS1 sends to the circuit design EWS2 the check sheet 4 together with the design data, such as the circuit connection information, the pattern and the like (Step S50).

The layout design EWS2 compares the execution inspection items noted in the check sheet 4 with the executed result, in response to the reception of the check sheet 4 (Step S51). If there is an inspection item in which the executed result is not noted in the inspection items to be executed, it is judged as a non-execution, and it is returned back to the circuit designer, and the inspection of the non-execution item is requested. If there is a result unsuitable for the layout as the result of the acceptance inspection, it is returned back to the circuit designer, and the improvement based on the re-design is requested (Step S52). If the layout has no problem in all the inspection items, the inspection result together with the circuit feature and the circuit designer ID is

written to the model development history database 7.

After that, the layout designer designs the
layout (Step S53). After the design of the layout,
the back annotation is carried out (Step S54). In the
back annotation, it is confirmed whether or not the
semiconductor integrated circuit carries out a
desirably functional operation at a delay after the
layout, and additionally writes its result to the
model development history database 7. If the result
of the back annotation is NG, it is returned back to
the circuit designer, and the improvement based on the
re-design is requested. If the result of the back
annotation is OK, the EB process is carried out (Step
S55).

Such a semiconductor circuit designing system
can clarify the inspection item to be executed without
any intervention of the network 3 by the circuit
design EWS1. In the logical design in which the
previous error is not displayed and the inspection
item is not exempted, a communication between the
circuit design EWS1 and the layout design EWS2 is
small and efficient. By the way, the inspection item
database may be simultaneously installed in both the
circuit design EWS1 and the layout design EWS2. In
this case, the semiconductor circuit designing system
is operated as shown in Figs. 12, 13, similarly to
this embodiment.

Another embodiment of the semiconductor
designing system according to the present invention
has a plurality of layout designs EWS. As shown in
Fig. 14, a layout design EWS2 belongs to a layout

5   designer A, and a layout design EWS2' belongs to a
layout designer B. The semiconductor designing system
according to another embodiment of the present
invention further includes a data center 8. The data
center 8 is connected to the network 3, and it has a

10   inspection item database 6 and a model development
history database 7.

The circuit EWS1 obtains the data of the
inspection item database 6 through the network 3 from
the data center 8. The layout EWS2 obtains the data

15   of the inspection item database 6 or the model
development history database 7 through the network 3
from the data center 8. The layout EWS2 further
updates the data of the model development history
database 7 through the network 3.

20   If each of the plurality of layouts EWS has the
inspection item database 6 and the model development
history database 7, the database is managed by each
layout EWS2, and the database is updated by each
layout EWS2. In the semiconductor designing system

25   according to another embodiment of the present
invention, the inspection item database 6 or the model
development history database 7 is unitarily managed.

It is easy to update the inspection item database 6 or the model development history database 7.

By the way, a layout EWS2 that is a part of the plurality of layouts EWS2 may also hold the function of the data center without separately installing the data center 8.

The semiconductor circuit designing apparatus and the semiconductor circuit designing method according to the present invention can avoid the occurrence of the problem in the later step in advance by providing the inspection items in the acceptance inspection to the circuit designer.

The present application claims priority under 35 U.S.C. § 119 to Japanese Patent Application No. 2000-354306, filed at 21 day of November, 2000, entitled "A semiconductor circuit designing apparatus and a semiconductor circuit designing method". The contents of that application are incorporated herein by reference in their entirety.